IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Osamu Nozawa et al.)
Serial No.:	10/771,997)
Filed:	February 4, 2004)
For: Manufacturing Method And Apparatus of Phase Mask Shift Blank))
Examiner:	Rodney Glenn McDonald)
Confirmation No.: 4072)
Art Unit:	1753)

AMENDMENT G (AFTER FINAL)

Commissioner of Patents P. O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants have the following response to the Final Rejection of April 26, 2007, a RCE and a three month extension of time being submitted herewith.

Please amend the above-identified application as follows: